## Xiuyan Li

## List of Publications by Year in descending order

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		1937685	1872680	
11	87	4	6	
papers	citations	h-index	g-index	
11	11	11	159	
all docs	docs citations	times ranked	citing authors	

#	Article	IF	CITATIONS
1	Flexible bioelectrodes with enhanced wrinkle microstructures for reliable electrochemical modification and neuromodulation in vivo. Biosensors and Bioelectronics, 2019, 135, 181-191.	10.1	37
2	Stepwise internal potential jumps caused by multiple-domain polarization flips in metal/ferroelectric/metal/paraelectric/metal stack. Nature Communications, 2020, 11, 1895.	12.8	14
3	Effect of nitrogen passivation on interface composition and physical stress in SiO2/SiC(4H) structures. Applied Physics Letters, 2018, 113, .	3.3	12
4	Direct relationship between sub-60 mV/dec subthreshold swing and internal potential instability in MOSFET externally connected to ferroelectric capacitor. , 2018, , .		9
5	Interface reaction kinetics in SiGe oxidation. Applied Physics Letters, 2019, 115, .	3.3	6
6	Analysis of Using Negative Capacitance FETs to Optimize Linearity Performance for Voltage Reference Generators. IEEE Transactions on Electron Devices, 2021, 68, 5864-5871.	3.0	3
7	Analytical Formulation of SiO $<$ inf $>$ 2 $<$ /inf $>$ -lL scavenging in HfO $<$ inf $>$ 2 $<$ /inf $>$ /Si gate stacks - A key is the SiO $<$ inf $>$ /Si interface reaction. , 2014, , .		2
8	The electronics transport mechanism of grain and grain boundary in semiconductive hafnium oxynitride thin film. Journal of Materials Science, 2020, 55, 2881-2890.	3.7	2
9	Kinetic model for scavenging of SiO <inf>2</inf> interface layer in HfO <inf>2</inf> gate stacks. , 2014, , .		1
10	On the physical origins of time-dependent steep SS in FeFET. , 2020, , .		1
11	Self-decomposition of SiO <sub>2</sub> due to Si-chemical potential increase in SiO <sub>2</sub> between HfO <sub>2</sub> and substrate - Comprehensive understanding of SiO <sub>2</sub> -lL scavenging in HfO <sub>2</sub> gate stacks on Si, SiGe and SiC., 2015, , .		0